



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Dennison et al.

Serial No.: 10/020,741

Filed: December 12, 2001

Patent No.: 5,270,241

Issued: December 14, 1993

For: OPTIMIZED CONTAINER-STACKED CAPACITOR DRAM CELL UTILIZING SACRIFICIAL OXIDE DEPOSITION AND CHEMICAL MECHANICAL POLISHING

Confirmation No.: 2283

Examiner: T. Nguyen

Group Art Unit: 2813

Attorney Docket No.: 3259.1US

(91-473.02/RE)

CERTIFICATE OF MAILING

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RESPONSE

Mail Stop NON-FEE AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed April 18, 2003, the three-month shortened statutory period for response to which expires on July 18, 2003.

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Listing of the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.